

b 25
the [wire] stem has a diameter between 0.0007 and 0.003
inches; and
the nickel has a thickness between 0.00010 and 0.003
inches.

[] Cancel claims 244-266, without prejudice.

b 26
41 267. (AMENDED) Method, according to claim [266] 15, wherein:
[the] a plurality of [wire] stems are arranged in an
array pattern on [the] a surface of the electronic component.

[] Cancel claims 268-277, without prejudice.

IN THE SPECIFICATION:

At the top of page 1, change the title of the invention from
"MANUFACTURING RAISED ELECTRICAL CONTACTS HAVING CONTROLLED
GEOMETRY" to -- METHOD OF MANUFACTURING ELECTRICAL CONTACTS, USING
A SACRIFICIAL MEMBER --